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	Application No.	Applicant(s)
Notice of Allowability	10/690 622	CHOO ET AL.
	10/689,633 Examiner	Art Unit
	A411 - O1	0074
	Mike Qi	2871
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. This communication is responsive to the amendment of July 5, 2005.		
2. The allowed claim(s) is/are <u>1-15 and 17</u> .		
3. X The drawings filed on 22 October 2003 are accepted by the Examiner.		
4.		
Attachment(s)  1. Notice of References Cited (PTO-892)  2. Notice of Draftperson's Patent Drawing Review (PTO-948)  3. Information Disclosure Statements (PTO-1449 or PTO/SB/O Paper No./Mail Date  4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☐ Interview Summary Paper No./Mail Dat 98), 7. ☐ Examiner's Amendr	te

Application/Control Number: 10/689,633

Art Unit: 2871

## **DETAILED ACTION**

## Allowable Subject Matter

- 1. Claims 1-15 and 17 are allowed.
- 2. The following is an examiner's statement of reasons for allowance:

The prior art of record neither discloses nor teaches that a method of manufacturing a liquid crystal display device comprising various steps as claimed, more specifically, as the following:

the mother substrates are erected to be disposed parallel to the gravitational force direction and transferred after the thin film transistor unit cells and the color filter unit cells are formed on the two mother substrates [claim 1].

The closest reference such as Us 2002/0173060 A1 (Hiroki) discloses that using non-contact inspection method to inspect the liquid crystal cells by reading with CCD or the like a pattern formed on a substrate and by comparing the read pattern with a reference pattern. The prior art of record do not disclose that during manufacturing process the two mother substrates are erected to be disposed parallel to a gravitational force direction and transferred so as to manufacture the liquid crystal display device after the unit cells formed on the two mother substrate as claimed.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Application/Control Number: 10/689,633

Art Unit: 2871

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Mike Qi whose telephone number is (571) 272-2299. The examiner can normally be reached on M-T 8:00 am-5:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert Kim can be reached on (571) 272-2293. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Mike Qi Patent Examiner

ROBERT KIM SUPERVISORY PATENT EXAMINER